



Attorney Docket No. 0553-0184.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Shunpei YAMAZAKI et al

Serial No: 10/642,803

Filed: August 18, 2003

Art Unit:

For: SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF

)
) I hereby certify that this correspondence
) is being deposited with the United States
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) Shannon Wallace
)
)

)
)
) Date: 9/8/03

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. A copy of each of the references was submitted to the Patent Office or was cited by the Examiner in the parent application, Serial No. 09/573,314, filed May 18, 2000, which is being relied upon for an earlier filing date under 35 U.S.C. 120 (37 C.F.R. §1.98(d)).

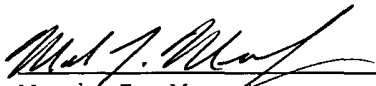
No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

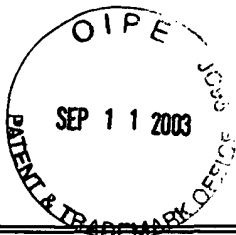
Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

A first office action, notice of allowance or issue fee notification has not been received in this case, so applicant does not believe that a fee is due. However, if any such fee is required, please charge our Deposit Account No. 50/1039.

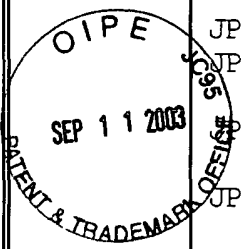
Respectfully submitted,


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LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Atty. Docket No.</u> 0553-0184.01	<u>Serial No.</u> 10/642,803		
			<u>Applicant</u> Shunpei YAMAZAKI et al			
			<u>Filing Date</u> August 18, 2003	<u>Group</u>		
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	5,463,483	10/31/95	Yamazaki	359	58	03/30/93
	5,485,019	01/16/96	Yamazaki et al	257	57	02/03/93
	5,576,857	11/09/96	Takemura	359	59	03/30/93
	5,595,638	01/21/97	Konuma et al	205	96	03/10/95
	5,643,826	07/01/97	Ohtani et al	437	88	10/25/94
	5,650,636	07/22/97	Takemura et al	257	59	06/01/95
	5,712,495	01/27/98	Suzawa	257	51	03/10/97
	5,729,308	03/17/98	Yamazaki et al	349	39	02/15/96
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	5,995,186	11/30/99	Hiroshi	349	141	04/04/97
	5,998,841	12/07/99	Suzawa	257	350	10/05/98
	6,013,930	01/11/00	Yamazaki et al	257	353	09/22/98
	6,100,947	08/08/00	Katayama	349	38	06/04/98
	6,165,824	12/26/00	Takano et al	438	160	03/03/98
	6,344,884 B1	02/05/02	Kim et al	349	43	11/25/98

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	DOCUMENT NUMBER	DATE	NAME	English Abstract	English Trans.	FILING DATE
	JP 6-160878	06/07/94	Hitachi Ltd.	X		09/10/93
	JP 7-130652	05/19/95	Semiconductor	X		10/29/93
	JP 9-211477	08/15/97	Energy Lab Co. Ltd. Semiconductor	X		01/31/96
	JP 9-211495	08/15/97	Energy Lab Co. Ltd. Semiconductor	X		01/31/96
	JP 10-247735	09/14/98	Energy Lab Co. Ltd. Semiconductor	X		03/03/97
	JP 2000- 122071 A	04/28/00	Energy Lab Co. Ltd. Yamada et al			10/13/98
OTHER PRIOR ART - NON-PATENT LITERATURE DOCUMENTS (Including Author, Title, Date, Pertinent Pages)						
	SHIMOKAWA, R. et al, "Characterization of High-Efficiency Cast-Si Solar Cell Wafers by MBIC Measurement," Japanese Journal of Applied Physics, vol. 27, no. 5, pp. 751-758, May (1988).					
EXAMINER:				DATE CONSIDERED:		
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.						